Under the Paperwork Reduction Act of 1995, no persons are required to respond to a collection of Information unless it displays a valid OMB control number.

Examiner Name

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

stitute for form 1449/PTO

Complete if Known Application Number 10/558,438 Filing Date March 19, 2007 First Named Inventor LEE, Koon-Seok Art Unit 2619

Mitchell, Daniel D.

(use as many sheets as necessary)

Sheet 1 1 7950.046.00 of Attorney Docket Number

U.S. PATENT DOCUMENTS						
Examiner Initials*	Cite No.1	Document Number Number-Kind Code ² (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	
/D.M./		4,980,913	12-25-1990	Skret	- I sales i ppesi	
/D.M./		6,006,272	12-21-1999	Aravamudan et al.		
/D.M./		6,160,808	12-12-2000	Maurya		
DM/		6,507,953 B1	01-14-2003	Horlander et al.		
/D.M./		6,735,619 B1	05-11-2004	Sawada		
DM/		7,103,834 B1	09-05-2006	Humpleman et al.		
/D.M./		2002/0103898 A1	08-01-2002	Mover et al.		
/D M /		2003/0079000 A1	04-24-2003	Chamberlain		
/D.M./		2003/0083758 A1	05-01-2003	Williamson		
D.M./		7,069,091 B2	06-27-2006	Williamson		
D.M./		7,454,517 B2	11-18-2008	Ha et al.		
D.M./		2007/0019615 A1	01-25-2007	Baek et al.		
DM/		2007/0025368 A1	02-01-2007	Ha et al.	-	
DM/		6,415,313 B1	07-02-2002	Yamada et al.		
D.M./	_	6,759,946 B2	07-06-2004	Sahinoglu et al.		
DM/		6,987,462 B2	01-17-2006	Bae et al.		
DM/		2002/0038358 A1	03-28-2002	Sweatt, III et al.		
D.M./		2002/0059617 A1	05-16-2002	Terakado et al.		
D.M./		2003/0038730 A1	02-27-2003	Imafuku et al.		
D.M./		2003/0088703 A1	05-08-2003	Kim		
			-			
					<u> </u>	

FOREIGN PATENT DOCUMENTS								
Examiner Initials*	Cite No.1	Foreign Patent Document Country Code³ -Number⁴-Kind Code⁵ (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear			
	ВА							

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. ¹ Applicant's unique citation designation number (optional). ² See Kinds Codes of USPTO Patent Documents at www.uspto.gov or MPEP 901.04. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the application number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁶ Applicant is to place a check mark here if English language Translation is attached.

NON PATENT LITERATURE DOCUMENTS						
Examiner Initials	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), and/or country where published.		T ²			
•	CA					

^{*}EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Examiner Signature	/Daniel Mitchell/	Date Considered	04/10/2009
		^	

Applicant's unique citation designation number (optional). ²Applicant is to place a check mark here if English language Translation is attached.